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(54) **Optical Ultrasonic receiving apparatus and ultrasonic diagnosing apparatus using the same**
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Appareil de réception optique à ultrasons et appareil diagnostique à ultrasons employant cet appareil

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(73) Proprietor: **Fuji Photo Film Co. Ltd.**
Kanagawa 250-0193 (JP)

(72) Inventor: **Ogawa, Eiji**
Ashigarakami-gun,
Kanagawa 258-8538 (JP)

(74) Representative: **Klunker . Schmitt-Nilson . Hirsch**
Winzererstrasse 106
80797 München (DE)

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Description

BACKGROUND OF THE INVENTION

Field of the Invention

[0001] The present invention generally relates to an ultrasonic receiving apparatus for receiving ultrasonic waves. More specifically, the present invention is directed to an ultrasonic diagnosing apparatus to be used in medical diagnoses by receiving ultrasonic waves from biological bodies with employment of such an ultrasonic receiving apparatus.

Description of a Related Art

[0002] In conventional ultrasonic diagnosing apparatus, while both ultrasonic transmitting means and ultrasonic receiving means use the same systems, one-dimensional sensor array is generally employed which includes elements (vibrators) for transmitting/receiving ultrasonic waves. The vibrators are realized by using piezoelectric ceramics which is typically known as PZT (Pb (lead) zirconate titanate), or by using a polymer piezoelectric element such as PVDF (polyvinylidene difluoride). Furthermore, such a one-dimensional sensor array is mechanically moved so as to acquire two-dimensional images, and those two-dimensional images are synthesized with each other, so that a three-dimensional image is obtained.

[0003] However, since there is a time lag along the mechanically moving direction of the one-dimensional sensor array in accordance with this method, tomographic images acquired at different time instants are synthesized with each other, and therefore, the synthesized image becomes blurred. As a result, this conventional method is not suitable for imaging objects to be inspected such as living bodies, for instance, in such a case where ultrasonic echo observations are carried out by employing the above-described conventional ultrasonic diagnosing apparatus.

[0004] In order to acquire a three-dimensional image having a high image quality by using ultrasonic waves, a two-dimensional sensor array capable of acquiring a two-dimensional image without being mechanically moved is necessarily required. For this reason, such a method of manufacturing a two-dimensional sensor array with employment of the above-described PZT or PVDF has been considered. In such a case where the above-described PZT or PVDF is employed so as to manufacture such a two-dimensional sensor array, elements must be processed in very fine manners, and also, a very large number of very fine elements must be connected by using wiring lines. However, it is practically difficult to process these elements in a finer manner, and also to manufacture these elements in a higher integration, as compared with the presently-available very fine processing manner and element integration method.

[0005] Also, even when these problems could be solved, there are other problems. That is, crosstalk between elements would be increased, electric impedance of elements connected by very fine wiring lines would be increased which deteriorate an S/N ratio thereof, and electrode portions of these very fine elements would be easily destroyed. Under such a circumstance, it is practically difficult to realize such a two-dimensional sensor array with employment of PZT or PVDF elements.

[0006] On the other hand, as another ultrasonic sensor without using a piezoelectric material such as PZT, an optical detecting type sensor is known in this field, by which an optical fiber is utilized and an ultrasonic wave is converted into an optical signal to be detected. As such an optical detecting type ultrasonic sensor, the below-mentioned ultrasonic sensors are reported, namely, an optical detecting type sensor using the fiber Bragg grating (will be abbreviated as an "FBG" hereinafter) described in "Underwater Acoustic Sensor with Fiber Bragg Grating" written by TAKAHASHI et al. in National Defense Academy (Japan), see OPTICAL REVIEW Vol. 4, No. 6 in 1997, p. 691-694 XPII61296; and an optical detecting type sensor using the Fabry-Perot resonator (will be abbreviated as an "FPR" hereinafter) described in "Fabrication and Performance of a Fiber Optic Micro-Probe for Megahertz Ultrasonic Field Measurements" written by UNO et al. in Tokyo Institute of Technology, see T. IEE Japan, Vol. 118-E, No. 11 in 1998, p. 487-492 XP8020301.

[0007] If such a two-dimensional sensor array is manufactured by employing these ultrasonic sensors, there are such merits that electric-wiring works to a large number of very fine elements are no longer required, and furthermore, higher sensitivities can be obtained. However, this two-dimensional sensor owns another problem that since this ultrasonic sensor itself is made in high cost, manufacturing cost of a two-dimensional sensor is increased, and also, manufacturing cost of an ultrasonic receiving apparatus using the two-dimensional sensor array is increased.

[0008] Wilkens V et al: "Optical multilayer detection array for fast ultrasonic field mapping" Optics Letters Vol. 24, No. 15, 1999 Optical Society of America, Washington, US XP973108 discloses an ultrasonic receiving apparatus in which an ultrasonic detecting element receives ultrasonic waves for modulating light on the basis of such waves. A photo detector comprising a plurality of pixels is provided for detecting light output from different positions of the ultrasonic detecting element.

[0009] Beard PC et al: "An optical detection system for biomedical photoacoustic imaging" Proceedings of the Spie 3916(2000) - The International Society for Optical Engineering Spie-Int. Soc. Opt. Eng USA XP2296331 discloses a biomedical imaging apparatus having a constitution similar to the above prior art constitution.

SUMMARY OF THE INVENTION

[0010] The present invention has been made to solve the above-described problems. A first object of the present invention is to provide an ultrasonic receiving apparatus capable of detecting an ultrasonic wave in a two-dimensional manner without necessities of electric-wiring works to a large number of very fine elements and without increase of crosstalk and impedance, and furthermore, to manufacture the ultrasonic receiving apparatus in low cost. Also, a second object of the present invention is to provide an ultrasonic diagnosing apparatus capable of acquiring either a two-dimensional ultrasonic image or a three-dimensional ultrasonic image by using the above-described ultrasonic receiving apparatus.

[0011] To solve the above-explained problems, an ultrasonic receiving apparatus according to the present invention comprises the features of claim 1.

[0012] Also, an ultrasonic diagnosing apparatus according to one aspect of the present invention comprises the features of claim 10.

[0013] According to the present invention, since the ultrasonic detecting element having the ultrasonic reception plane including positions which correspond to a plurality of pixels of the photodetector is employed, such an ultrasonic receiving apparatus can be manufactured in low cost. That is to say, this ultrasonic receiving apparatus is capable of detecting the ultrasonic waves in a two-dimensional manner without necessities of electric-wiring works to the large number of very fine elements and without increase of crosstalk and impedance. Accordingly, an ultrasonic diagnosing apparatus capable of acquiring a two-dimensional or three-dimensional ultrasonic image with better qualities can be realized by employing such an ultrasonic receiving apparatus.

BRIEF DESCRIPTION OF THE DRAWINGS

[0014] A better understanding of the present invention will become apparent from a detailed description to be read in conjunction with the accompanying drawings, in which:

Fig. 1 is a diagram for schematically showing an arrangement of an ultrasonic receiving apparatus according to an example useful for understanding the present invention;

Fig. 2 is a diagram for illustratively showing an ultrasonic detecting element as shown in Fig. 1 in an enlarging mode;

Fig. 3 is a diagram for schematically showing one modification of the ultrasonic receiving apparatus as shown in Fig. 1;

Fig. 4 is a diagram for schematically showing an embodiment of the ultrasonic receiving apparatus according to the present invention;

Fig. 5 is a diagram for illustratively showing a basic

idea of an ASE light source as shown in Fig. 4;

Fig. 6 is a block diagram for showing an arrangement of an ultrasonic diagnosing apparatus according to one embodiment of the present invention;

Fig. 7 is a block diagram for showing an arrangement of one modification of an ultrasonic diagnosing apparatus as shown in Fig. 6;

Fig. 8 is a diagram for explaining a reception method executed in the case where ultrasonic beams are limited into a pencil beam and this pencil beam is transmitted;

Fig. 9 is a diagram for explaining a reception method executed in the case where ultrasonic beams are limited to a plane-shaped beam and this plane-shaped beam is transmitted; and

Fig. 10 is a diagram for explaining a reception method executed in the case where ultrasonic beams are transmitted as plane waves.

20 DESCRIPTION OF THE PREFERRED EMBODIMENTS

[0015] Referring now to drawings, various embodiments of the present invention will be described in detail. It should be understood that the same reference numerals are employed as those for indicating the same or similar structural elements, and explanations thereof are omitted.

[0016] Fig. 1 is a diagram for schematically showing a basic structure of an ultrasonic receiving apparatus according to one embodiment of the present invention.

[0017] This ultrasonic receiving apparatus includes a light source 11, a beam separator 12, an ultrasonic detecting element 20, a focusing system 15, and a photodetector 16. The light source 11 generates single mode laser light having a single wavelength of, for example, 500nm to 1600nm. The beam separator 12 is constructed by a half mirror, an optical circulator, a polarization beam splitter, or the like. This beam separator 12 may pass therethrough incident light entered from a first direction toward a second direction, and furthermore, may pass therethrough reflection light returned from the second direction toward a third direction which is different from the first direction. In this embodiment, a half mirror is employed as the beam separator 12. This half mirror 12 passes therethrough incident light and reflects thereon the reflection light which returns from a direction opposite to the incident direction so that this reflected light is propagated to a direction at substantially 90 degrees with respect to the incident direction. Alternatively, in this case, before the incident light enters the beam separator 12 along the light propagation direction, this incident light may be expanded by a beam expander 13.

[0018] The ultrasonic detecting element (multi-layer film sensor) 20 includes a base plate 21 and multi-layer film 22 stacked on the base plate 21. The ultrasonic detecting element 20 has a wave receiving plane where distortion occurs by receiving propagated ultrasonic waves. The ultrasonic detecting element 20 reflects the

light which is emitted from the light source 11 and entered into the multi-layer film 22 through the beam separator 12, while modulating the light on the basis of ultrasonic waves applied to the base plate 21. The light reflected from the ultrasonic detecting element 20 is reflected by the beam separator 12 and entered into the photodetector 16 having a plurality of pixels.

[0019] The photodetector 16 corresponds to a two-dimensional array detector which is constituted by a CCD, an MOS type sensor, a plurality of PD (photodiodes) or the like. The photodetector 16 detects, for a plurality of pixels, the light which is entered from corresponding positions of the ultrasonic detecting element 20 via the beam separator 12. This photodetector 16 outputs detection signals in accordance with intensity of light at the respective pixels. In this case, the reflection light may be directly entered into the photodetector 16, or may be entered via an optical fiber or the like into the photodetector 16. Further, while the focusing system 15 such as a lens or the like is provided at a rear stage of the beam separator 12, the reflection light may be focused via this focusing system 15 onto the photodetector 16.

[0020] Now, both a structure of the above-described ultrasonic detecting element 20 and a principle idea of detecting ultrasonic waves will be described in detail with reference to Fig. 2.

[0021] The base plate 21 is a film-shaped base plate where distortion occurs by receiving ultrasonic waves. This base plate 21 is shaped of, for example, a circle having a diameter of about 2cm or larger. Two sorts of materials having different refractive indexes are alternately stacked on this base plate 21 so as to form the multi-layer film 22 having a Bragg grating structure. In Fig. 2, there are shown a material layer "A" having a refractive index " n_1 " and another material layer "B" having a refractive index " n_2 ".

[0022] Assuming now that a pitch (an interval) of a periodic structure of the multi-layer film 22 is equal to "d" and a wavelength of incident light is equal to " λ ", the Bragg's reflection condition is expressed by the following expression:

$$2d \cdot \sin \theta = m \lambda \quad \dots \quad (1)$$

where symbol "m" represents an arbitrary integer, and symbol " θ " represents an incident angle of the incident light which is measured from an incident plane.

[0023] Assuming again that this incident angle " θ " is equal to $\pi/2$, the Bragg's reflection condition is given by the following expression:

$$2d = m \lambda \quad \dots \quad (2)$$

The Bragg grating selectively reflects thereon such a

light having a specific wavelength which satisfies the Bragg's reflection condition, and passes therethrough light having other wavelengths than the above-described specific wavelength.

5 [0024] When the ultrasonic waves are propagated through the ultrasonic detecting element 20, this ultrasonic detecting element 20 is distorted in accordance with the propagation of the ultrasonic waves, and therefore, the pitch "d" of the periodic structure is changed at the respective positions of the multi-layer film 22. As a result, the wavelength " λ " of the light, which is selectively reflected, is changed. In a reflection characteristic of a Bragg grating, an inclined band where reflectance is varied is present before or after a center wavelength where the reflectance becomes the highest (namely, the transmittance becomes lowest). While such a detection light having a center wavelength which is located within the range of this inclined band is entered into the multi-layer film 22, the ultrasonic waves are applied to the multi-layer film 22. As a result, intensity changes of the reflection light (otherwise the transmission light) in accordance with intensity of the ultrasonic waves at the respective positions of the ultrasonic wave receiving plane can be monitored. Since the intensity changes of the reflection light (or transmission light) are converted into intensity of ultrasonic waves, two-dimensional intensity distribution information of those ultrasonic waves can be acquired.

[0025] As a material of the above-described base plate 21, quartz glass (SiO_2) or optical glass such as BK7 (manufactured by Schott Glass) or the like may be employed. Also, as a substance used in the material layers "A" and "B", it is preferable to employ a combination of substances having refractive indexes which are different from each other by 10% or more. In other words, in the case of such a refractive index relationship of $n_1 < n_2$, such substances capable of satisfying $n_1 \times 1.1 \leq n_2$ are selected. This selection condition is to achieve a high reflectance at a boundary plane between the material layer "A" and the material layer "B". Also, both the material layers "A" and "B" are preferably made of such a material which can be easily expanded/compressed. This selection condition is to increase sensitivities when ultrasonic waves are applied to those material layers "A" and "B". As the combination of such substances capable of satisfying such conditions, there are a combination of SiO_2 and a titanium oxide (Ti_2O_3), another combination of SiO_2 and a tantalum oxide (Ta_2O_5) and the like. For instance, in the former case, the refractive index of SiO_2 is nearly equal to 1.45 and the refractive index of Ti_2O_3 is nearly equal to 2.0 with respect to laser light having a wavelength of 1520nm. This fact may sufficiently satisfy the above-described condition. That is, the refractive indexes of those materials are different from each other by 10% or more.

55 [0026] A layer thickness (film thickness) of the material layer "A" and a layer thickness (film thickness) of the material layer "B" are preferably selected to be substantially 1/4 of the wavelength " λ " of the light which is entered

into the multi-layer film 22. In this case, an expression "film thickness" implies an optical distance which is expressed by a product of a refractive index "n" of a material layer and a thickness "t" of the material layer. In other words, " $n \cdot t = \lambda/4$ " may constitute the condition. As a consequence, the pitch of the periodic structure of the multi-layer film 22 becomes substantially 1/2 of the wavelength of the incident light, and the multi-layer film 22 can selectively reflect thereon the light having such a wavelength satisfying the above-described expression (2) of the Bragg's reflection condition and pass therethrough the light having other wavelengths than the above-described wavelength.

[0027] Alternatively, while some material layers "A" and "B" each having a layer thickness of substantially $\lambda/4$ are alternatively stacked with each other, some material layers "A" and "B" each having a layer thickness of substantially $\lambda/2$ may be intermittently stacked.

[0028] The above-mentioned material layers "A" and "B" are stacked on the substrate 21 in such a manner that multiple layers (for example, 100 layers) of each of those materials are formed thereon by way of a vapor deposition method, a sputtering method, or the like.

[0029] In connection with the above-described principle idea, a simulation was made under the following condition. In this simulation, SiO_2 was used as the base plate, and both SiO_2 and Ti_2O_3 were employed as the material layers. When laser light was entered into a multi-layer film sensor having a total number of 200 material layers (100 layers for each material), the below-mentioned results could be obtained. That is, an inclination of reflectance with respect to a change in wavelengths of incident light was 2.8dB/0.01nm at the reflectance of 25%.

[0030] Thus, when the total layer number of the multi-layer film is increased, the reflectance becomes higher, and also, the reflectance changes steeply with respect to a change in the wavelengths of incident light, so that the sensitivity of the ultrasonic detecting element 2 can be increased.

[0031] Next, a modification of the above-explained ultrasonic receiving apparatus will now be described with reference to Fig. 3.

[0032] This modified ultrasonic receiving apparatus is arranged by adding at least one of an optical amplifier 1 and another optical amplifier 2 to the ultrasonic receiving apparatus as shown in Fig. 1. The optical amplifier 1 is positioned either between the light source 11 and the beam separator 12 or between the beam expander 13 and the beam separator 12. This optical amplifier 1 optically amplifies the light entered from the light source 11, and then emits the amplified light to the beam separator 12. On the other hand, the optical amplifier 2 is positioned between the beam separator 12 and the focusing system 15 such as the lens. This optical amplifier 2 amplifies the light entered from the beam separator 12, and then emits the amplified light to the focusing system 15. In the case where this focusing system 15 is not employed, the optical amplifier 2 is positioned between the beam separator

12 and the photodetector 16, and amplifies the light entered from the beam separator 12 to emit the amplified light to the photodetector 16.

[0033] As the optical amplifier, for example, such an optical fiber amplifier EDFA (Er-doped optical fiber amplifier) is used into which erbium (Er) has been doped. This EDFA can increase intensity of light by about 10^1 to 10^2 times.

[0034] In the case where such an optical amplifier is positioned between the light source 11 and the ultrasonic detecting element 20, intensity of incident light which is entered into this ultrasonic detecting element 20 is amplified. Also, in the case where such an optical amplifier is arranged between the ultrasonic detecting element 20 and the photodetector 16, intensity of incident light which is entered into the ultrasonic detecting element 20 is not changed, but intensity of reflection light which is entered into the photodetector 16 is amplified. In this case, a change in the intensity of the reflection light which is modulated by the received ultrasonic waves is also amplified.

[0035] In either case, since the intensity of light is amplified, the light amount of the reflection light which is entered into the photodetector 16 is increased. As a result, an adverse influence of electric noise occurred in the photodetector 16 can be reduced, and the S/N (signal-to-noise) ratio of the ultrasonic receiving apparatus can be improved. In addition, in the case where both the optical amplifiers 1 and 2 are employed, the S/N ratio of this ultrasonic receiving apparatus can be furthermore improved.

[0036] Next, the embodiment of the ultrasonic receiving apparatus will now be explained with reference to Fig. 4 and Fig. 5. An ultrasonic receiving apparatus as shown in Fig. 4 is realized by replacing the light source 11 of the ultrasonic receiving apparatus as shown in Fig. 1 by another light source, namely a broadband light source. In this second modified embodiment as shown in Fig. 4, a spectrum of the light which is generated from the broadband light source is narrowed by a narrow-band filter, and then, the narrow-band light is employed.

[0037] As the broadband light source, for example, an ASE (amplified spontaneous emission) light source for emitting amplified spontaneous emission light, and a broadband optical fiber light source may be employed. In Fig. 4, an ASE light source 17 is used as the broadband light source. This ASE light source 17 is realized by changing a structure of a broadband optical fiber amplifier so as to emit the amplified spontaneous emission light. The detailed structure or operation of the broadband optical fiber amplifier is described in, for example, "BROADBAND OPTICAL FIBER AMPLIFIER" written by H.OKOSHII et al. (see Japanese Electronic Information Communication Institute Publication Vol. 82, No. 7, 1999, pp. 718-724).

[0038] Now, referring to Fig. 5, Fig. 5 illustratively shows a basic idea of the ASE light source 17 as shown in Fig. 4. This ASE light source 17 includes an optical fiber 4 for amplifying light. A lens 5 is mounted on one

edge portion of this optical fiber 4, and a Bragg grating portion 6 capable of reflecting excitation light is formed on the other edge portion thereof. A laser oscillator 7 is arranged as an excitation light source on a left side of the lens 5, in this drawing. Laser light which is generated from the laser oscillator 7 is entered via the lens 5 into the optical fiber 4, and then, this entered laser light is amplified by this optical fiber 4. A portion of this amplified laser light may pass through the Bragg grating portion 6 as spontaneous emission light.

[0039] Referring back to Fig. 4, the light generated from the ASE light source 17 is entered into the beam separator 14. This beam separator 14 passes the light entered from a first direction to a second direction, and also, passes the reflection light returned from the second direction to a third direction which is different from the first direction. In Fig. 4, a half mirror is employed as the beam separator 14. Alternatively, an optical circulator or a polarization beam splitter may be employed.

[0040] In a direction (namely, lower side of Fig. 4) along which the light emitted from the ASE light source 17 passes through the beam splitter 14, a narrow-band filter 23 is provided which is made of the same material as that of the ultrasonic detecting element 20. The light which is entered into this narrow-band filter 23 is reflected by a multi-layer film having a Bragg grating structure included in the narrow-band filter 23, and then, this reflected light is again entered into the beam separator 14. The spontaneous emission light generated from the ASE light source 17 passes through the narrow-band filter 23, so that a spectrum of this spontaneous emission light can be narrowed.

[0041] The light reflected by the narrow-band filter 23 is again entered into the beam separator 14, and the propagation path of this light is changed, and then, the resultant light is entered into the beam separator 12. The light which has passed through the beam separator 12 is entered into the ultrasonic detecting element 20 so as to be modulated.

[0042] In this case, as to a Bragg grating portion, a center wavelength of reflection light is changed due to a temperature variation in a ratio of $0.01\text{nm}/^\circ\text{C}$. As a result, when a light source for generating laser light having a single wavelength is employed, there is such a problem that the sensitivity of the ultrasonic detecting element 20 which is constituted by the Bragg grating portion is largely changed in accordance with a temperature variation.

[0043] However, when the spectrum of the spontaneous emission light generated from the ASE light source 17 is narrowed by the narrow-band filter 23 as shown in Fig. 4, a bandwidth which is approximated to that of the laser light having a single wavelength can be secured, and also, the change in the sensitivities of the ultrasonic receiving apparatus due to the temperature variation can be reduced.

[0044] That is, both the narrow-band filter 23 and the ultrasonic detecting element 20 are made by employing the same material, and thermal coupling therebetween

is established by, for example, coupling the narrow-band filter 23 to the ultrasonic detecting element 20 by employing such a material having a high thermal conductivity or physically locating the narrow-band filter 23 in proximity to the ultrasonic detecting element 20. Alternatively, a heat pipe may be arranged around the narrow-band filter 23 and the ultrasonic detecting element 20.

[0045] As a consequence, since the temperature at the Bragg grating portion of the narrow-band filter 23 can be made substantially equal to the temperature at the Bragg grating portion of the ultrasonic detecting element 20, even when the reflection characteristic of the ultrasonic detecting element 20 is shifted by the temperature, the wavelength of the light which is entered into the ultrasonic detecting element 20 is similarly shifted, so that the change in the sensitivities of the ultrasonic receiving apparatus can be reduced.

[0046] Next, an ultrasonic diagnosing apparatus according to one embodiment of the present invention will be described with referring to Fig. 6. Fig. 6 is a schematic block diagram for showing an arrangement of an ultrasonic diagnosing apparatus according to this embodiment.

[0047] This ultrasonic diagnosing apparatus is constituted by applying thereto the above-described ultrasonic receiving apparatus. That is, the ultrasonic detecting element 20 as shown in Fig. 2 is employed in an ultrasonic detecting unit 50 of this ultrasonic diagnosing apparatus. As shown in Fig. 6, this ultrasonic diagnosing apparatus includes an ultrasonic transmitting unit 40 and a drive signal generating circuit 30. The ultrasonic transmitting unit 40 transmits ultrasonic waves in accordance with drive signals generated from the drive signal generating circuit 30. The ultrasonic transmitting unit 40 includes a material (piezoelectric element) having a piezoelectric characteristic. This piezoelectric element is realized by piezoelectric ceramics which is typically known as PZT (Pb (lead) zirconate titanate), or a polymer piezoelectric element such as PVDF (polyvinyl difluoride). When either a pulse-shaped electric signal or a continuous-wave (CW) electric signal is transmitted from the drive signal generating circuit 30 so as to apply a voltage to such a piezoelectric element, this piezoelectric element produces very small mechanical vibrations. Since such mechanical vibrations are produced, either ultrasonic pulses or continuous-wave (CW) ultrasonic waves are generated from this piezoelectric element, and then, are propagated as ultrasonic beams through a propagation medium.

[0048] The ultrasonic waves transmitted from the ultrasonic transmitting unit 40 are reflected from a diagnostic object, and then, the reflected ultrasonic waves (namely, ultrasonic echoes) are received by the ultrasonic detecting unit 50. While the light which has been generated from the light source and has passed through the beam separator 12 is entered into the ultrasonic detecting unit 50, this light is modulated on the basis of the ultrasonic beams applied to the ultrasonic detecting unit 50, and then, this modulated light is reflected from this ultra-

sonic detecting unit 50. The reflected light is entered via the beam separator 12 and the focusing system 15 into the photodetector 16 so as to be detected in a two-dimensional manner.

[0049] This ultrasonic diagnosing apparatus further includes a signal processing means 60 including both a signal processing unit 61 and an A/D converter 62, a timing control unit 70, a primary storage unit 80, an image processing unit 90, an image display unit 100, and a secondary storage unit 110.

[0050] In the signal processing means 60, a detection signal output from the photodetector 16 is entered into a signal processing unit 61, and the detection signal processed by the signal processing unit 61 is converted into a digital signal in the A/D converter 62.

[0051] The primary storage unit 80 stores thereinto plural sheets of plane data acquired by the signal processing means 60. The image processing unit 90 reconstructs either two-dimensional data or three-dimensional data on the basis of these plane data, and also, executes such process operations as an interpolation process, a response modulation process, and a gradation process. The image display unit 100 corresponds to a display apparatus such as a CRT or an LCD, for example, and displays thereon an image on the basis of the image data to which these process operations have been carried out. Further, the secondary storage unit 110 stores thereinto data which has been processed by the image processing unit 90.

[0052] The timing control unit 70 controls the drive signal generating unit 30 to generate the drive signal at predetermined timing, and also controls the signal processing unit 61 to acquire detection signals from the photodetector 16 after a predetermined time period has passed from a transmission time instant. Thus, the timing control unit 70 controls both timing of the drive signal and timing of the detection signal so as to limit a readout time range, so that reflections of ultrasonic waves from a specific depth of an object to be inspected can be optically detected.

[0053] Next, a description will now be made of a modification of the ultrasonic diagnosing apparatus according to this embodiment with reference to Fig. 7. As shown in Fig. 7, in this modified ultrasonic diagnosing apparatus, both the ultrasonic detecting unit 50 and the ultrasonic transmitting unit 40 are formed in an integral manner, so that an ultrasonic probe 120 is formed.

[0054] Since an optical detecting type ultrasonic detector does not own a function of transmitting ultrasonic waves, such an ultrasonic transmitting unit using a piezoelectric element must be separately provided. As to the modification as shown in Fig. 7, since both the ultrasonic transmitting unit and the ultrasonic detecting unit, which employ the different systems, are combined with each other to form a single probe. This modified ultrasonic diagnosing apparatus is capable of performing the ultrasonic diagnosing operation, while having a similar operation feeling as that of the conventional probe with

employment of the same transmission/reception system.

[0055] In the ultrasonic diagnosing apparatus as shown in Fig. 6 and Fig. 7, the below-mentioned three sorts of transmission methods of ultrasonic waves may be conceived in the drive signal generating circuit 30 and the ultrasonic transmitting unit 40. In response to these ultrasonic wave transmission methods, data acquisition time instants and contents of data in the signal processing unit 61 are changed.

(1) In the case where ultrasonic waves are limited to form a pencil-beam-shaped ultrasonic beam, and then, this pencil-beam-shaped ultrasonic beam is transmitted:

As shown in Fig. 8, if transmission waves are spatially limited to form a pencil-beam-shaped ultrasonic beam by the ultrasonic transmitting unit 40, an object to be inspected is scanned within a certain plane in the two-dimensional manner, and then, detection signals of ultrasonic echoes which have been received after a predetermined time period has elapsed from a transmission thereof is acquired by the ultrasonic detecting unit 50, ultrasonic information at the respective points on this plane can be acquired. When this operation is carried out within a sectional view which is located at a constant depth from the ultrasonic detecting unit 50, sectional plane information at a constant depth can be acquired. When a series of the above-described processing steps are repeatedly carried out by changing the acquisition time at each of the pencil beam positions, a plurality of tomographic images at different depths can be acquired. The sample data which have been acquired in the above-described manner are focused both in the transmission/reception operations, and therefore, may be directly displayed as three-dimensional data.

(2) In the case where ultrasonic waves are limited to form a plane-shaped ultrasonic wave, and then, this plane-shaped ultrasonic wave is transmitted:

Also, as shown in Fig. 9, if the transmission ultrasonic waves generated from the ultrasonic transmitting unit 40 are limited to form a plane-shaped ultrasonic wave by using an acoustic lens, and also detection signals of ultrasonic echoes which have been received after a predetermined time period has elapsed from the transmission of the ultrasonic transmission waves are acquired by the ultrasonic detecting unit 50, then one-dimensional line information of a certain depth can be acquired in a batch manner. In this case, since information of other points in the region to which the ultrasonic waves

are applied is also mixed with the information as to the respective points, it would be necessary to carry out the wave-front synthesizing operation (so-called "aperture synthesizing operation") on the basis of the detection signals, the acquisition time instants of which are shifted, and then, to reconstruct the data where focal points are coincident with each other so as to obtain a display image.

(3) In the case where ultrasonic waves are transmitted as plane waves:

Furthermore, as shown in Fig. 10, if the transmission ultrasonic waves are transmitted as a plane-shaped wave from the ultrasonic transmitting unit 40, and also detection signals of ultrasonic echoes which have been received after a predetermined time period has elapsed from the transmission of the ultrasonic waves are acquired by the ultrasonic detecting unit 50, then two-dimensional plane information at a certain depth can be acquired in a batch manner. When this process step is repeatedly carried out while the acquisition time is changed, a plurality of tomographic images at the different depths can be acquired. In this case, since information of other points in the region to which the ultrasonic waves are applied is also mixed with the information as to the respective points, it would be necessary to carry out the wave-front synthesizing operation (so-called "aperture synthesizing operation") on the basis of the detection signals, the acquisition time instants of which are shifted, and then, to reconstruct the data where focal points are coincident with each other so as to obtain a display image.

[0056] As previously described in detail, in accordance with the present invention, since an ultrasonic detecting element having an ultrasonic receiving plane corresponding to a plurality of pixels of a photodetector is employed, ultrasonic waves can be detected in a two-dimensional manner. Such an ultrasonic detecting element can be manufactured in low cost, as compared with a case where a plurality of fiber Bragg gratings are formed into an array. As a result, the manufacturing cost of the ultrasonic receiving apparatus can be lowered. Also, layers of a multi-layer film as the ultrasonic detecting element are formed one by one in the vapor deposition method, the sputtering method or the like, a plurality of materials having largely different refractive indexes can be selected. As a consequence, inclination of the reflectance can be increased, and the sensitivity of the ultrasonic receiving apparatus can be improved. By using the ultrasonic diagnosing apparatus which employs such an ultrasonic receiving apparatus, either two-dimensional or three-dimensional ultrasonic images having better qualities can

be acquired.

Claims

1. An ultrasonic receiving apparatus comprising:

a broadband light source (17);
 a narrow-band filter (23) for narrowing a spectrum of light generated from said broadband light source;
 an ultrasonic detecting element (20) having a reception plane capable of receiving ultrasonic waves and a Bragg grating structure (22) for modulating the light outputted from said narrow-band filter (23) on the basis of ultrasonic waves applied to respective positions of said reception plane; and
 a photodetector (16) having a plurality of pixels, for detecting light output from corresponding positions of said ultrasonic detecting element, wherein said narrow-band filter (23) has a Bragg grating structure constituted by using the same material as that of the Bragg grating structure of said ultrasonic detecting element (20); and
 the Bragg grating structure of said narrow-band filter (23) is thermally coupled to the Bragg grating structure of said ultrasonic detecting element (20).

2. An ultrasonic receiving apparatus according to claim 1, wherein said ultrasonic detecting element (20) includes a multi-layer film (22) formed by alternately stacking two sorts of materials having different refractive indexes from each other by at least 10%.

3. An ultrasonic receiving apparatus according to claim 2, wherein layers of said two sorts of materials which constitute said multi-layer film (22) include a layer having a film thickness of substantially 1/4 of the wavelength of light, which is entered into said multi-layer film.

4. An ultrasonic receiving apparatus according to claim 3, wherein layers of said two sorts of materials which constitute said multi-layer film (22) further include a layer having a film thickness of substantially 1/2 of the wavelength of light, which is entered into said multi-layer film.

5. An ultrasonic receiving apparatus according to claim 1, wherein said photodetector (16) includes any one of a CCD (charge-coupled device), a MOS (metal oxide semiconductor) type sensor, and a plurality of photodiodes.

6. An ultrasonic receiving apparatus according to claim 1, further comprising:

- a beam expander (13) for expanding light outputted from said narrow-band filter (23).
7. An ultrasonic receiving apparatus according to claim 1, further comprising:
- an optical amplifier (1) for amplifying light outputted from said narrow-band filter (23) to enter the amplified light into said ultrasonic detecting element (20).
8. An ultrasonic receiving apparatus according to claim 1, further comprising:
- an optical amplifier (2) for amplifying light output from said ultrasonic detecting element (20) to enter the amplified light into said photodetector (16).
9. An ultrasonic receiving apparatus according to claim 1, wherein said broadband light source includes an ASE (amplified spontaneous emission) light source (17) for emitting amplified spontaneous emission light.
10. An ultrasonic diagnosing apparatus comprising:
- a drive signal generating circuit (30) for generating drive signals;
 transmission means (40) for transmitting ultrasonic waves in response to the drive signals;
 reception means including said ultrasonic receiving apparatus according to any one of claims 1-9 to thereby output detection signals;
 signal processing means (60) for receiving the detection signals output from said reception means to process the received detection signals;
 control means (70) for controlling both generation timing of the drive signals and acquisition timing of the detection signals;
 image processing means (90) for constructing image data on the basis of an output signal of said signal processing means (60); and
 an image display unit (100) for displaying thereon an image on the basis of the image data.
11. An ultrasonic diagnosing apparatus according to claim 10, wherein said transmission means (40) belongs to a piezoelectric type ultrasonic transmission means for generating ultrasonic waves in response to voltage applied thereto.
12. An ultrasonic diagnosing apparatus according to claim 10, wherein:
- both said transmission means (40) and said ultrasonic detecting element (20) included in said

detection means are formed in an integral shape to thereby constitute an ultrasonic wave probe (120).

Patentansprüche

1. Ultraschallempfangsvorrichtung, umfassend:
- eine Breitband-Lichtquelle (17);
 ein schmalbandiges Filter (23) zum Schmälern eines Lichtspektrums, welches von der Breitband-Lichtquelle erzeugt wird;
 ein Ultraschall-Detektorelement (20) mit einer Empfangsebene, die in der Lage ist, Ultraschallwellen zu empfangen, und einer Bragg-Gitterstruktur (22) zum Modulieren des von dem schmalbandigen Filter (23) ausgegebenen Lichts auf der Grundlage von Ultraschallwellen, die an einzelnen Stellen der Empfangsebene aufgebracht werden; und
 einen Photodetektor (16) mit einer Mehrzahl von Pixeln zum Nachweisen des von entsprechenden Stellen des Ultraschall-Detektorelements ausgegebenen Lichts, wobei das schmalbandige Filter (23) eine Bragg-Gitterstruktur besitzt, gebildet durch Verwenden des gleichen Materials wie bei der Bragg-Gitterstruktur des Ultraschall-Detektorelements (20); und
 wobei die Bragg-Gitterstruktur des schmalbandigen Filters (23) thermisch mit der Bragg-Gitterstruktur des Ultraschall-Detektorelements (20) gekoppelt ist.
2. Vorrichtung nach Anspruch 1, bei der das Ultraschall-Detektorelement (20) einen mehrlagigen Film (22) enthält, gebildet durch abwechselndes Stapeln zweier Materialsorten mit Brechungsindizes, die sich voneinander um mindestens 10 % unterscheiden.
3. Vorrichtung nach Anspruch 2, bei der Schichten der beiden Materialsorten des mehrlagigen Films (22) eine Lage mit einer Filmdicke von etwa 1/4 der Wellenlänge desjenigen Lichts enthalten, welches in den mehrlagigen Film eintritt.
4. Vorrichtung nach Anspruch 3, bei der Schichten der beiden Sorten von Materialien des mehrlagigen Films (22) weiterhin eine Lage mit einer Filmdicke von etwa 1/2 der Wellenlänge desjenigen Lichts enthalten, welches in den mehrlagigen Film eintritt.
5. Vorrichtung nach Anspruch 1, bei der der Photodetektor (16) ein CCD-Bauelement (ladungsgespeistes Bauelement), einen MOS-Sensor (Metalloxid-Halbleiter-Sensor) oder eine Mehrzahl von Photodioden enthält.

6. Vorrichtung nach Anspruch 1, weiterhin umfassend einen Strahlaufweiter (13) zum Aufweiten von Licht, welches von dem schmalbandigen Filter (23) ausgegeben wird.
7. Vorrichtung nach Anspruch 1, weiterhin umfassend einen optischen Verstärker (1) zum Verstärken von Licht aus dem schmalbandigen Filter (23), um das verstärkte Licht in das Ultraschall-Detektorelement (20) einzugeben.
8. Vorrichtung nach Anspruch 1, weiterhin umfassend einen optischen Verstärker (2) zum Verstärken des von dem Ultraschall-Detektorelement (20) ausgegebenen Lichts, um das verstärkte Licht in den Photodetektor (16) einzugeben.
9. Vorrichtung nach Anspruch 1, bei der die Breitband-Lichtquelle eine ASE-Lichtquelle (für verstärkte spontane Emission) (17) zum Emittieren von verstärktem spontanem Emissionslicht enthält.
10. Ultraschall Diagnosevorrichtung, umfassend:
- eine Treibersignalerzeugungsschaltung (30) zum Erzeugen von Treibersignalen;
 - eine Übertragungseinrichtung (40) zum Übertragen von Ultraschallwellen ansprechend auf die Treibersignale;
 - eine Empfangseinrichtung mit einer Ultraschall-empfangsvorrichtung nach einem der Ansprüche 1 bis 9, um Detektorsignale auszugeben;
 - eine Signalverarbeitungseinrichtung (60) zum Empfangen der von der Empfangseinrichtung ausgegebenen Detektorsignale, um die empfangenen Detektorsignale zu verarbeiten;
 - eine Steuereinrichtung (70) zum Steuern sowohl der Erzeugungszeit der Treibersignale als auch der Aufnahmezeit der Detektorsignale;
 - eine Bildverarbeitungseinrichtung (90) zum Aufbauen von Bilddaten auf der Grundlage eines Ausgangssignals der Signalverarbeitungseinrichtung (60); und
 - eine Bildanzeigeeinheit (100) zum Anzeigen eines Bilds auf der Grundlage der Bilddaten.
11. Vorrichtung nach Anspruch 10, bei der die Übertragungseinrichtung (40) zu einer piezoelektrischen Ultraschallübertragungseinrichtung gehört, die Ultraschallwellen ansprechend auf eine angelegte Spannung erzeugt.
12. Vorrichtung nach Anspruch 10, bei der sowohl die Übertragungseinrichtung (40) als auch das Ultraschall-Detektorelement (20) in der Detektoreinrichtung durch eine integrale Form ausgebildet sind, um eine Ultraschallwellensonde (120) zu bilden.

Revendications

1. Appareil de réception à ultrasons comprenant :

5 une source de lumière à large bande (17) ;
 un filtre à bande étroite (23) destiné à rétrécir un spectre de lumière généré par ladite source de lumière à large bande ;
 un élément de détection à ultrasons (20) ayant un plan de réception capable de recevoir des ondes ultrasonores et une structure à réseau de Bragg (22) pour moduler la lumière émise par ledit filtre à bande étroite (23) sur la base d'ondes ultrasonores appliquées à des positions respectives dudit plan de réception ; et
 10 un photodétecteur (16) ayant une pluralité de pixels, pour détecter l'émission de lumière provenant de positions correspondantes dudit élément de détection à ultrasons, dans lequel ledit filtre à bande étroite (23) a une structure à réseau de Bragg constituée en utilisant le même matériau que celui de la structure à réseau de Bragg dudit élément de détection à ultrasons (20) ; et
 15 la structure à réseau de Bragg dudit filtre à bande étroite (23) est thermiquement couplée à la structure à réseau de Bragg dudit élément de détection à ultrasons (20).

2. Appareil de réception à ultrasons selon la revendication 1, dans lequel ledit élément de détection à ultrasons (20) comprend un film à couches multiples (22) formé en empilant en alternance deux sortes de matériaux ayant des indices de réfraction différents l'un de l'autre d'au moins 10 %.

3. Appareil de réception à ultrasons selon la revendication 2, dans lequel les couches desdites deux sortes de matériaux qui constituent ledit film à couches multiples (22) comprennent une couche ayant une épaisseur de film correspondant sensiblement à 1/4 de la longueur d'onde de lumière, qui est entrée dans ledit film à couches multiples.

4. Appareil de réception à ultrasons selon la revendication 3, dans lequel les couches desdites deux sortes de matériaux qui constituent ledit film à couches multiples (22) comprennent en outre une couche ayant une épaisseur de film correspondant sensiblement à 1/2 de la longueur d'onde de lumière, qui est entrée dans ledit film à couches multiples.

5. Appareil de réception à ultrasons selon la revendication 1, dans lequel ledit photodétecteur (16) comprend l'un quelconque des éléments suivants : un CCD (dispositif à couplage de charge), un capteur de type MOS (métal-oxyde-semiconducteur), et une pluralité de photodiodes.

6. Appareil de réception à ultrasons selon la revendication 1, comprenant en outre :
- un dilatateur de faisceaux (13) pour dilater la lumière émise par ledit filtre à bande étroite (23). 5
7. Appareil de réception à ultrasons selon la revendication 1, comprenant en outre :
- un amplificateur optique (1) destinée à amplifier la lumière émise par ledit filtre à bande étroite (23) pour faire entrer la lumière amplifiée dans ledit élément de détection à ultrasons (20). 10
8. Appareil de réception à ultrasons selon la revendication 1, comprenant en outre :
- un amplificateur optique (2) destiné à amplifier la lumière émise par ledit élément de détection à ultrasons (20) pour faire entrer la lumière amplifiée dans ledit photodétecteur (16). 20
9. Appareil de réception à ultrasons selon la revendication 1, dans lequel ladite source de lumière à large bande comprend une source de lumière ASE (émission spontanée amplifiée) (17) destinée à émettre une lumière à émission spontanée amplifiée. 25
10. Appareil de diagnostic à ultrasons, comprenant en outre : 30
- un circuit de génération de signal d'entraînement (30) destiné à générer des signaux d'entraînement ;
- un moyen de transmission (40) destiné à transmettre des ondes ultrasonores en réponse aux signaux d'entraînement ; 35
- un moyen de réception comprenant ledit appareil de réception à ultrasons selon l'une quelconque des revendications 1 à 9 pour émettre ainsi des signaux de détection ; 40
- un moyen de traitement de signal (60) destiné à recevoir les signaux de détection émis par ledit moyen de réception afin de traiter les signaux de détection reçus ; 45
- un moyen de commande (70) destiné à commander à la fois le moment de génération des signaux d'entraînement et le moment d'acquisition des signaux de détection ;
- un moyen de traitement d'image (90) pour construire des données d'image sur la base d'un signal de sortie dudit moyen de traitement de signal (60) ; et 50
- une unité d'affichage d'image (100) destinée à y afficher une image sur la base des données d'image. 55
11. Appareil de diagnostic à ultrasons selon la revendication 10, dans lequel ledit moyen de transmission (40) appartient à un moyen de transmission à ultrasons de type piézoélectrique destiné à générer des ondes ultrasonores en réponse à une tension qui y est appliquée.
12. Appareil de diagnostic à ultrasons selon la revendication 10, dans lequel :
- ledit moyen de transmission (40) et ledit élément de détection à ultrasons (20) compris tous les deux dans ledit moyen de détection sont formés d'un seul tenant pour constituer ainsi une sonde à ondes ultrasonores (120).

FIG.1

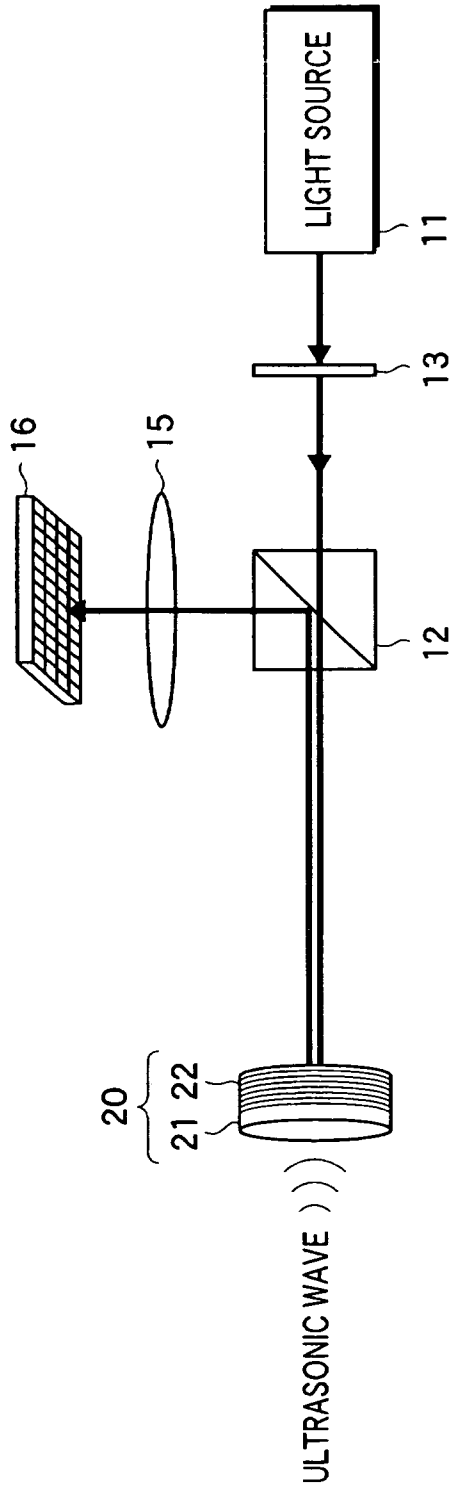


FIG.2

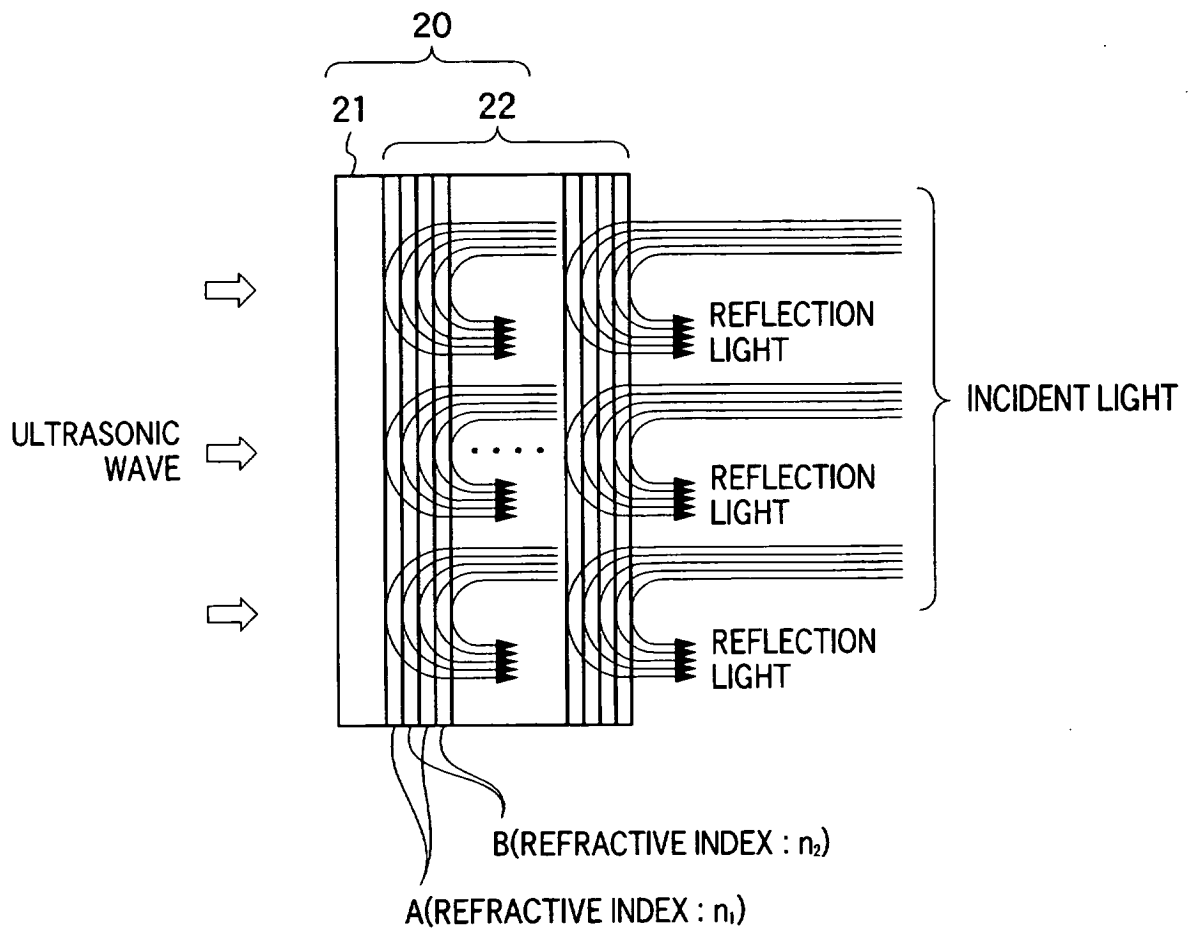


FIG.3

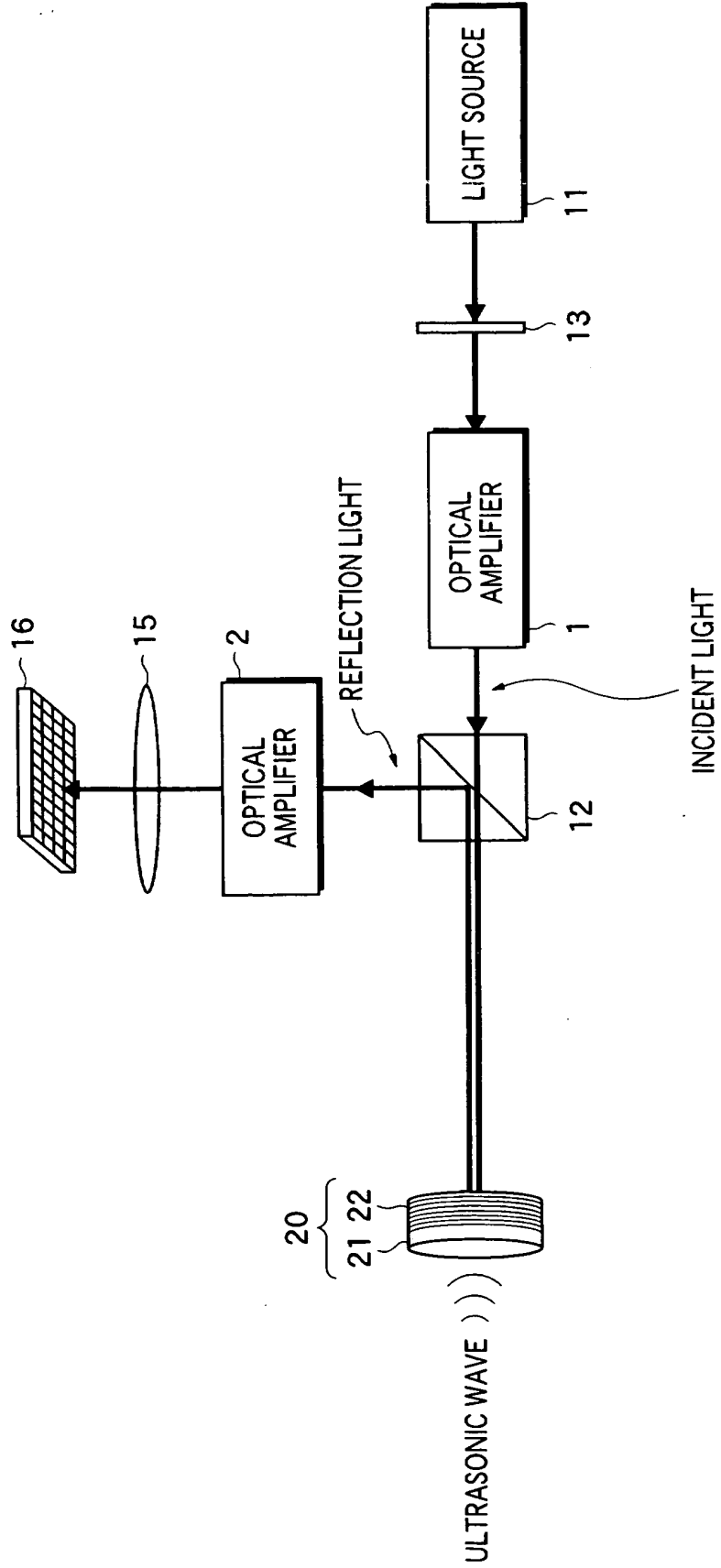


FIG.4

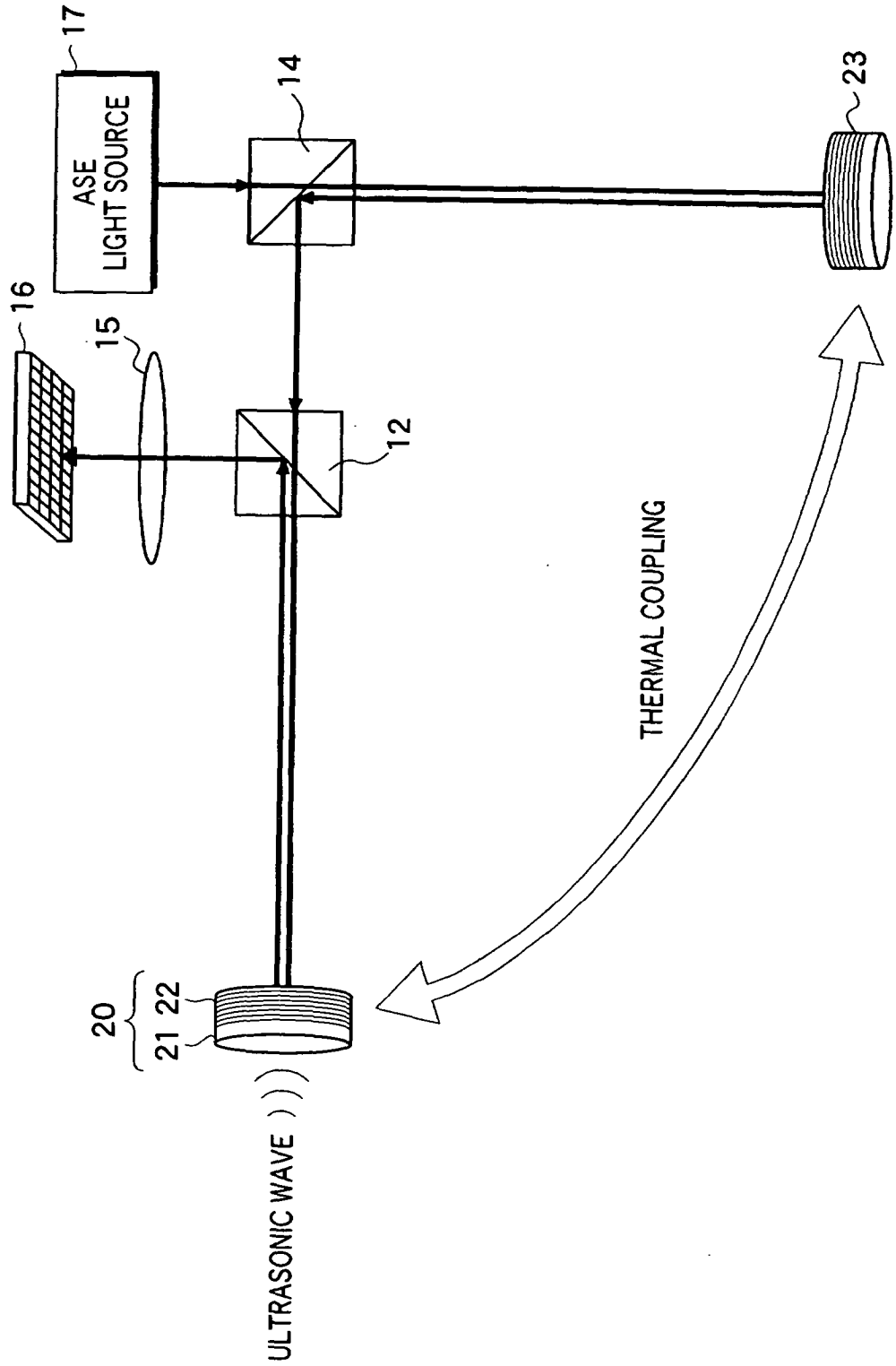


FIG.5

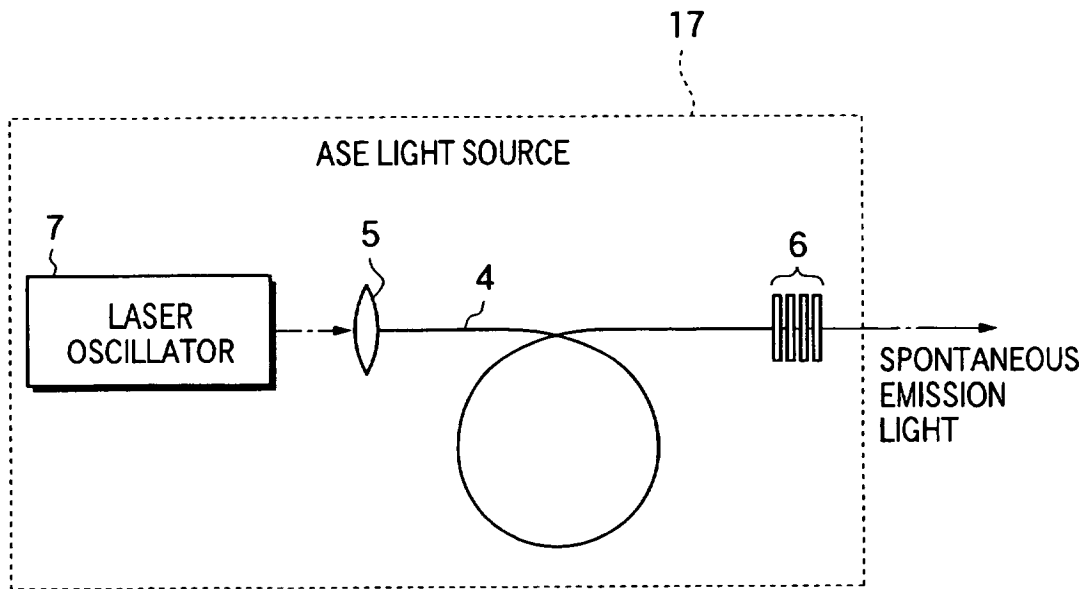


FIG.6

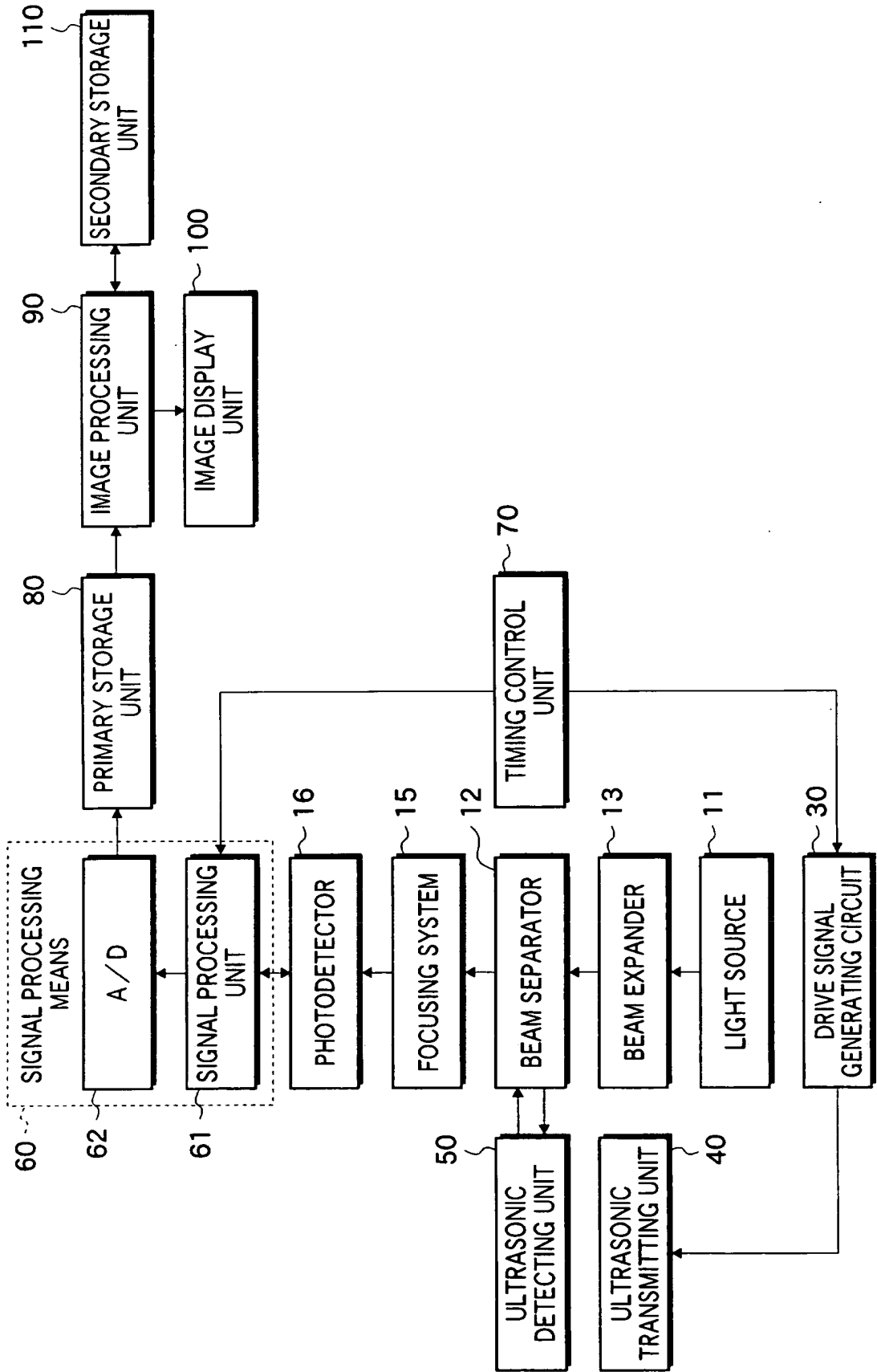


FIG. 7

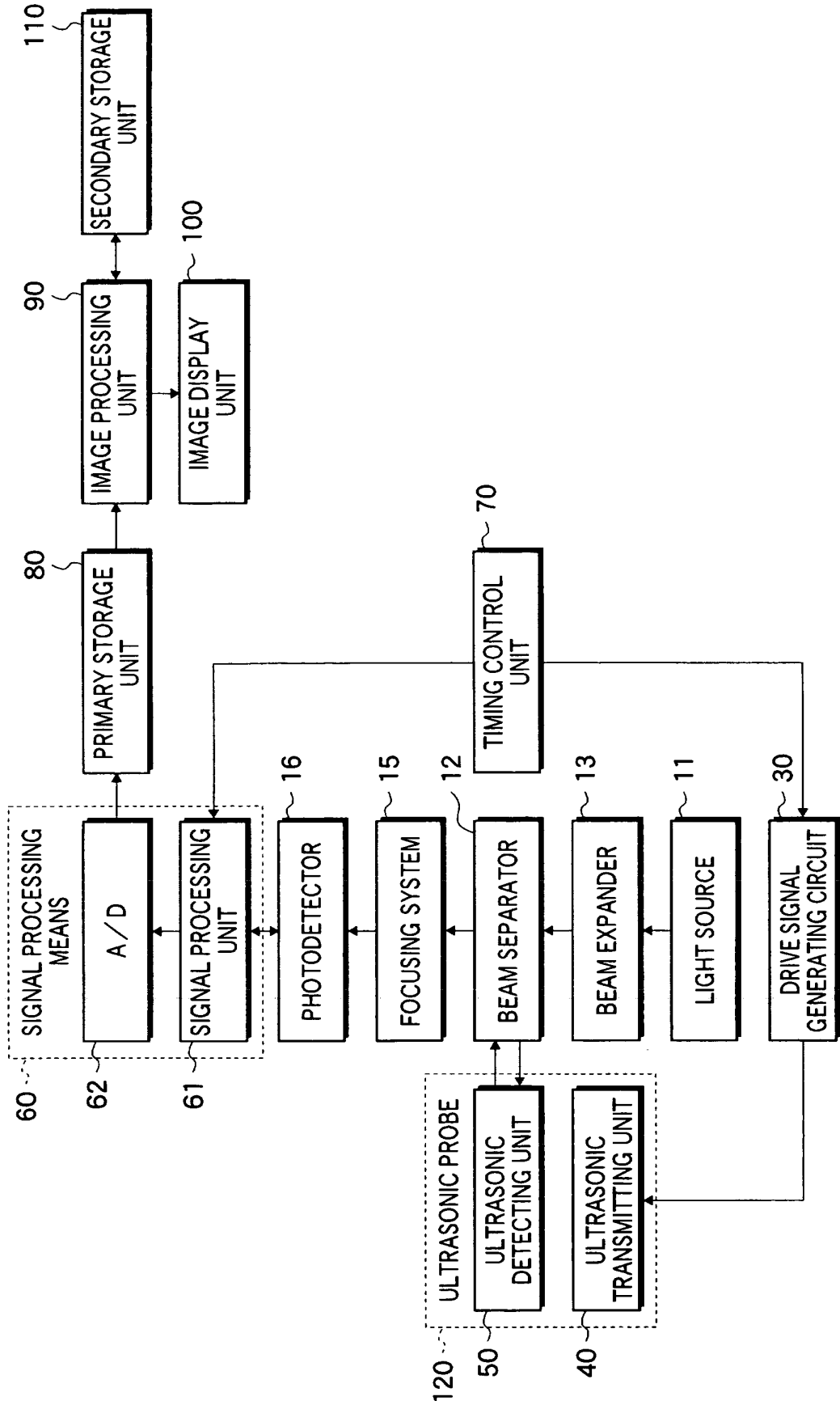


FIG.8

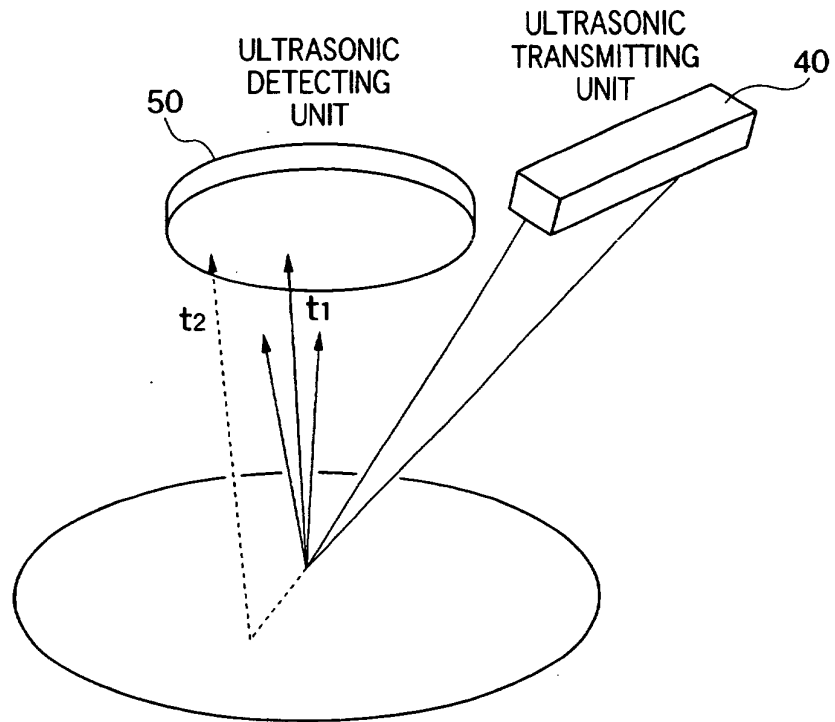


FIG.9

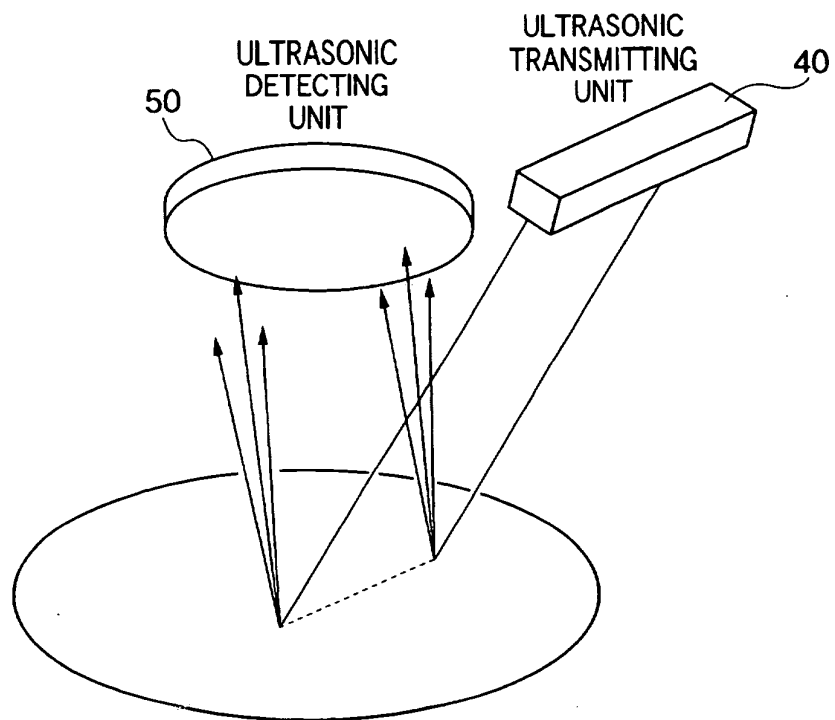
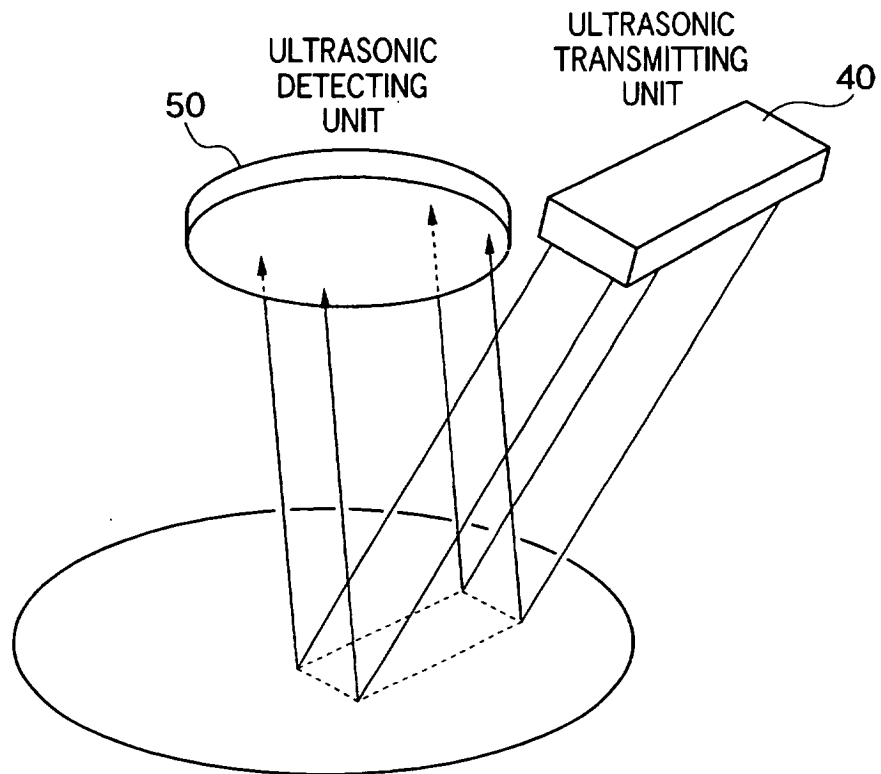


FIG.10



专利名称(译)	光学超声波接收装置和使用该装置的超声波诊断装置		
公开(公告)号	EP1298450B1	公开(公告)日	2006-11-15
申请号	EP2002021187	申请日	2002-09-24
[标]申请(专利权)人(译)	富士摄影胶片公司		
申请(专利权)人(译)	富士胶片CO.LTD.		
当前申请(专利权)人(译)	富士胶片株式会社		
[标]发明人	OGAWA EIJI		
发明人	OGAWA, EIJI		
IPC分类号	G01S7/52 A61B8/00 G01S15/89 A61B5/00 G02F1/11 H04R17/00		
CPC分类号	A61B5/0097 A61B5/0059 A61B8/00 G01S7/5205 G01S15/8968 G01S15/8993 G02F1/11 G02F2201/346		
优先权	2001296317 2001-09-27 JP		
其他公开文献	EP1298450A3 EP1298450A2		
外部链接	Espacenet		

摘要(译)

一种超声波接收装置，其中可以以二维方式检测超声波信号，而不需要电线，可以对大量非常精细的元件起作用，并且不会增加串扰和阻抗。超声波接收装置可以低成本制造。该超声波接收装置包括超声波检测元件20，该超声波检测元件20具有能够接收超声波的接收平面，用于基于施加到接收平面的各个位置的超声波来调制光。光电探测器16具有多个像素，用于检测从超声波探测元件的相应位置输出的光。

$$2d \cdot \sin \theta = m \lambda \quad \dots \quad (1)$$